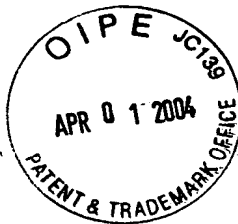


DOCKET NO: 221014US90PCT



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
YASUJI HIRAMATSU, ET AL. : EXAMINER: FUQUA, S.  
SERIAL NO: 10/070,443 :  
FILED: JUNE 24, 2002 : GROUP ART UNIT: 3742  
FOR: SEMICONDUCTOR :  
MANUFACTURING/TESTING CERAMIC  
HEATER, PRODUCTION METHOD FOR  
THE CERAMIC HEATER AND  
PRODUCTION SYSTEM FOR THE  
CERAMIC HEATER

AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated October 3, 2003, please amend the  
above-identified application as follows:

**Amendments to the Abstract** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page  
3 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.